HCTS75MS

Radiation Hardened Dual 2-Bit Bistable Transparent Latch

September 1995

Features

- 3 Micron Radiation Hardened SOS CMOS
- Total Dose 200K RAD (Si)
- SEP Effective LET No Upsets: >100 MEV-cm^2/mg
- Single Event Upset (SEU) Immunity < 2 x 10^{-9} Errors/Bit-Day (Typ)
- Dose Rate Survivability: >1 x 10^{12} RAD (Si)/s
- Dose Rate Upset >10^{10} RAD (Si)/s 20ns Pulse
- Latch-Up Free Under Any Conditions
- Military Temperature Range: -55^{o}C to +125^{o}C
- Significant Power Reduction Compared to LSTTL ICs
- DC Operating Voltage Range: 4.5V to 5.5V
- LSTTL Input Compatibility
  - VIL = 0.8V Max
  - VIH = VCC/2 Min
- Input Current Levels Ii $\leq$ 5μA at VOL, VOH

Description

The Intersil HCTS75MS is a Radiation Hardened dual 2-bit bistable transparent latch. Each of the two latches are controlled by a separate enable input ($\overline{E}$) which are active low. $\overline{E}$ low latches the output state.

The HCTS75MS utilizes advanced CMOS/SOS technology to achieve high-speed operation. This device is a member of radiation hardened, high-speed, CMOS/SOS Logic Family.

The HCTS75MS is supplied in a 16 lead Ceramic flatpack (K suffix) or a SBDIP Package (D suffix).

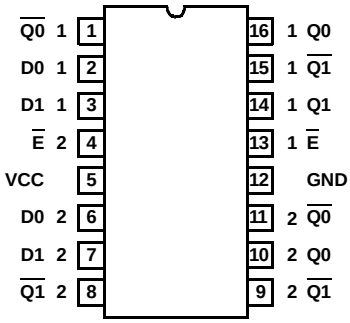
Ordering Information

PART NUMBER	TEMPERATURE RANGE	SCREENING LEVEL	PACKAGE
HCTS75DMSR	-55^{o}C to +125^{o}C	Intersil Class S Equivalent	16 Lead SBDIP
HCTS75KMSR	-55^{o}C to +125^{o}C	Intersil Class S Equivalent	16 Lead Ceramic Flatpack
HCTS75D/ Sample	+25^{o}C	Sample	16 Lead SBDIP
HCTS75K/ Sample	+25^{o}C	Sample	16 Lead Ceramic Flatpack
HCTS75HMSR	+25^{o}C	Die	Die

Pinouts

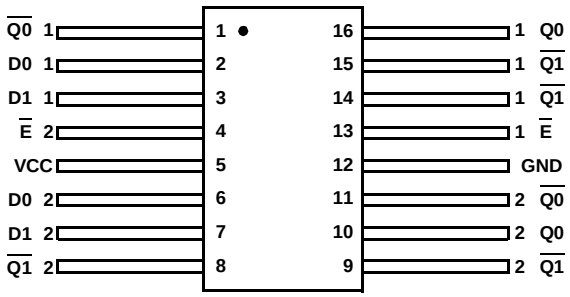
16 LEAD CERAMIC DUAL-IN-LINE METAL SEAL PACKAGE (SBDIP) MIL-STD-1835 CDIP2-T16, LEAD FINISH C

TOP VIEW

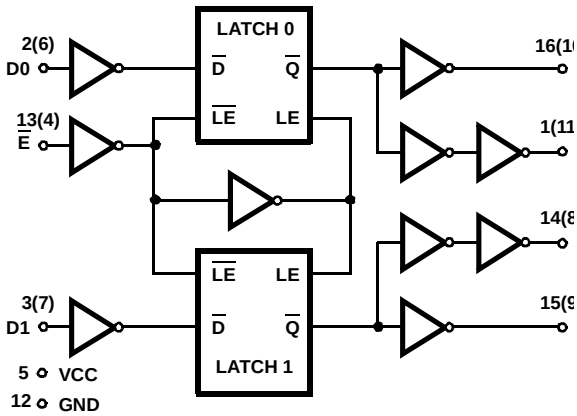


16 LEAD CERAMIC METAL SEAL FLATPACK PACKAGE (FLATPACK) MIL-STD-1835 CDFP4-F16, LEAD FINISH C

TOP VIEW



Functional Diagram



TRUTH TABLE

INPUTS		OUTPUTS	
D	E	Q	$\overline{Q}$
L	H	L	H
H	H	H	L
X	L	Q0	$\overline{Q0}$

Spec Number **518625**
FN3189.1

Absolute Maximum Ratings

Supply Voltage (VCC). . . . . -0.5V to +7.0V
Input Voltage Range, All Inputs . . . . . -0.5V to VCC +0.5V
DC Input Current, Any One Input . . . . . ±10mA
DC Drain Current, Any One Output. . . . . ±25mA
(All Voltage Reference to the VSS Terminal)
Storage Temperature Range (TSTG) . . . . . -65^oC to $+150^oC$
Lead Temperature (Soldering 10sec) . . . . . $+265^oC$
Junction Temperature (TJ) . . . . . $+175^oC$
ESD Classification . . . . . Class 1

Reliability Information

Thermal Resistance	θ_{JA}	θ_{JC}
SBDIP Package.	$73^oC/W$	$24^oC/W$
Ceramic Flatpack Package	$114^oC/W$	$29^oC/W$

Maximum Package Power Dissipation at $+125^oC$ Ambient
SBDIP Package. 0.68W
Ceramic Flatpack Package 0.44W
If device power exceeds package dissipation capability, provide heat sinking or derate linearly at the following rate:
SBDIP Package. . . . . $13.7mW/^oC$
Ceramic Flatpack Package . . . . . $8.8mW/^oC$

CAUTION: As with all semiconductors, stress listed under "Absolute Maximum Ratings" may be applied to devices (one at a time) without resulting in permanent damage. This is a stress rating only. Exposure to absolute maximum rating conditions for extended periods may affect device reliability. The conditions listed under "Electrical Performance Characteristics" are the only conditions recommended for satisfactory device operation.

Operating Conditions

Supply Voltage (VCC). . . . . +4.5V to +5.5V
Input Rise and Fall Times at VCC = 4.5V (TR, TF) . . . 100ns/V Max
Operating Temperature Range (T_A) . . . . . -55^oC to $+125^oC$
Input Low Voltage (VIL). . . . . 0.0V to 0.8V
Input High Voltage (VIH) . . . . . .VCC/2 to VCC

TABLE 1. DC ELECTRICAL PERFORMANCE CHARACTERISTICS

PARAMETER	SYMBOL	(NOTE 1) CONDITIONS	GROUP A SUB-GROUPS	TEMPERATURE	LIMITS MIN	LIMITS MAX	UNITS
Quiescent Current	ICC	VCC = 5.5V, VIN = VCC or GND	1	$+25^oC$	-	20	µA
			2, 3	$+125^oC$, -55^oC	-	400	µA
Output Current (Sink)	IOL	VCC = VIH = 4.5V, VOUT = 0.4V, VIL = 0V	1	$+25^oC$	4.8	-	mA
			2, 3	$+125^oC$, -55^oC	4.0	-	mA
Output Current (Source)	IOH	VCC = VIH = 4.5V, VOUT = VCC - 0.4V, VIL = 0V	1	$+25^oC$	-4.8	-	mA
			2, 3	$+125^oC$, -55^oC	-4.0	-	mA
Output Voltage Low	VOL	VCC = 5.5V, VIH = 2.75V, VIL = 0.8V, IOL = 50µA	1, 2, 3	$+25^oC$, $+125^oC$, -55^oC	-	0.1	V
		VCC = 4.5V, VIH = 2.25V, VIL = 0.8V, IOL = 50µA	1, 2, 3	$+25^oC$, $+125^oC$, -55^oC	-	0.1	V
Output Voltage High	VOH	VCC = 5.5V, VIH = 2.75V, VIL = 0.8V, IOH = -50µA	1, 2, 3	$+25^oC$, $+125^oC$, -55^oC	VCC -0.1	-	V
		VCC = 4.5V, VIH = 2.25V, VIL = 0.8V, IOH = -50µA	1, 2, 3	$+25^oC$, $+125^oC$, -55^oC	VCC -0.1	-	V
Input Leakage Current	IIN	VCC = 5.5V, VIN = VCC or GND	1	$+25^oC$	-0.5	+0.5	µA
			2, 3	$+125^oC$, -55^oC	-5.0	+5.0	µA
Noise Immunity Functional Test	FN	VCC = 4.5V, VIH = 2.25V, VIL = 0.8V (Note 2)	7, 8A, 8B	$+25^oC$, $+125^oC$, -55^oC	-	-	V

NOTES:
1. All voltages referenced to device GND.
2. For functional tests VO ≥ 4.0V is recognized as a logic "1", and VO ≤ 0.5V is recognized as a logic "0".

TABLE 2. AC ELECTRICAL PERFORMANCE CHARACTERISTICS

PARAMETER	SYMBOL	(NOTES 1, 2) CONDITIONS	GROUP A SUB-GROUPS	TEMPERATURE	LIMITS MIN	LIMITS MAX	UNITS
Propagation Delay D to Q	TPLH	VCC = 4.5V, VIH = 3.0V, VIL = 0V	9	+25°C	2	19	ns
			10, 11	+125°C, -55°C	2	24	ns
	TPHL	VCC = 4.5V, VIH = 3.0V, VIL = 0V	9	+25°C	2	27	ns
			10, 11	+125°C, -55°C	2	35	ns
Propagation Delay D to $\overline{Q}$	TPLH	VCC = 4.5V, VIH = 3.0V, VIL = 0V	9	+25°C	2	23	ns
			10, 11	+125°C, -55°C	2	29	ns
	TPHL	VCC = 4.5V, VIH = 3.0V, VIL = 0V	9	+25°C	2	19	ns
			10, 11	+125°C, -55°C	2	22	ns
Propagation Delay $\overline{E}$ to Q	TPLH	VCC = 4.5V, VIH = 3.0V, VIL = 0V	9	+25°C	2	21	ns
			10, 11	+125°C, -55°C	2	25	ns
	TPHL	VCC = 4.5V, VIH = 3.0V, VIL = 0V	9	+25°C	2	20	ns
			10, 11	+125°C, -55°C	2	23	ns
Propagation Delay $\overline{E}$ to $\overline{Q}$	TPLH	VCC = 4.5V, VIH = 3.0V, VIL = 0V	9	+25°C	2	24	ns
			10, 11	+125°C, -55°C	2	29	ns
	TPHL	VCC = 4.5V, VIH = 3.0V, VIL = 0V	9	+25°C	2	28	ns
			10, 11	+125°C, -55°C	2	34	ns

NOTES:

1. All voltages referenced to device GND.
2. Measurements made with RL = 500Ω, CL = 50pF, Input TR = TF = 3ns.

TABLE 3. ELECTRICAL PERFORMANCE CHARACTERISTICS

PARAMETER	SYMBOL	CONDITIONS	NOTES	TEMPERATURE	LIMITS MIN	LIMITS MAX	UNITS
Capacitance Power Dissipation	CPD	VCC = 5.0V, f = 1MHz	1	+25°C	-	36	pF
			1	+125°C, -55°C	-	51	pF
Input Capacitance	CIN	VCC = 5.0V, f = 1MHz	1	+25°C	-	10	pF
			1	+125°C, -55°C	-	10	pF
Pulse Width Time	TW	VCC = 4.5V, VIH = 4.5V, VIL = 0.0V	1	+25°C	-	16	ns
			1	+125°C, -55°C	-	24	ns
Setup Time	TSU	VCC = 4.5V, VIH = 4.5V, VIL = 0.0V	1	+25°C	-	12	ns
			1	+125°C, -55°C	-	18	ns
Hold Time	TH	VCC = 4.5V, VIH = 4.5V, VIL = 0.0V	1	+25°C	-	12	ns
			1	+125°C, -55°C	-	18	ns
Output Transition Time	TTHL, TTLH	VCC = 4.5V, VIH = 4.5V, VIL = 0.0V	1	+25°C		15	ns
			1	+125°C, -55°C		22	ns

NOTE:

1. The parameters listed in Table 3 are controlled via design or process parameters. Min and Max Limits are guaranteed but not directly tested. These parameters are characterized upon initial design release and upon design changes which affect these characteristics.

TABLE 4. DC POST RADIATION ELECTRICAL PERFORMANCE CHARACTERISTICS

PARAMETERS	SYMBOL	(NOTE 1) CONDITIONS	TEMPERATURE	200K RAD LIMITS		UNITS
				MIN	MAX	
Supply Current	ICC	VCC = 5.5V, VIN = VCC or GND	+25°C	-	0.4	mA
Output Current (Sink)	IOL	VCC = VIH = 4.5V, VOUT = 0.4V, VIL = 0V	+25°C	4.0	-	mA
Output Current (Source)	IOH	VCC = VIH = 4.5V, VOUT = VCC - 0.4V, VIL = 0V	+25°C	-4.0	-	mA
Output Voltage Low	VOL	VCC = 5.5V, VIH = 2.75V, VIL = 0.8V, IOL = 50µA	+25°C	-	0.1	V
		VCC = 4.5V, VIH = 2.25V, VIL = 0.8V, IOL = 50µA	+25°C	-	0.1	V
Output Voltage High	VOH	VCC = 5.5V, VIH = 2.75V, VIL = 0.8V, IOH = -50µA	+25°C	VCC -0.1	-	V
		VCC = 4.5V, VIH = 2.25V, VIL = 0.8V, IOH = -50µA	+25°C	VCC -0.1	-	V
Input Leakage Current	IIN	VCC = 5.5V, VIN = VCC or GND	+25°C	-5	+5	µA
Noise Immunity Functional Test	FN	VCC = 4.5V, VIH = 2.25V, VIL = 0.8V, (Note 3)	+25°C	-	-	
Propagation Delay D to Q	TPHL	VCC = 4.5V, VIH = 3.0V, VIL = 0V	+25°C	2	35	ns
	TPLH	VCC = 4.5V, VIH = 3.0V, VIL = 0V	+25°C	2	24	ns
Propagation Delay D to $\overline{Q}$	TPHL	VCC = 4.5V, VIH = 3.0V, VIL = 0V	+25°C	2	22	ns
	TPLH	VCC = 4.5V, VIH = 3.0V, VIL = 0V	+25°C	2	29	ns
Propagation Delay $\overline{E}$ to Q	TPHL	VCC = 4.5V, VIH = 3.0V, VIL = 0V	+25°C	2	23	ns
	TPLH	VCC = 4.5V, VIH = 3.0V, VIL = 0V	+25°C	2	25	ns
Propagation Delay $\overline{E}$ to $\overline{Q}$	TPHL	VCC = 4.5V, VIH = 3.0V, VIL = 0V	+25°C	2	34	ns
	TPLH	VCC = 4.5V, VIH = 3.0V, VIL = 0V	+25°C	2	29	ns

NOTES:

1. All voltages referenced to device GND.
2. AC measurements assume RL = 500Ω, CL = 50pF, Input TR = TF = 3ns, VIL = GND, VIH = 3V.
3. For functional tests VO ≥ 4.0V is recognized as a logic “1”, and VO ≤ 0.5V is recognized as a logic “0”.

TABLE 5. BURN-IN AND OPERATING LIFE DELTA PARAMETERS (+25°C)

PARAMETER	GROUP B SUBGROUP	DELTA LIMIT
ICC	5	±6µA
IOL/IOH	5	-15% of 0 Hour

TABLE 6. APPLICABLE SUBGROUPS

CONFORMANCE GROUPS		METHOD	GROUP A SUBGROUPS	READ AND RECORD
Initial Test (Preburn-In)		100%/5004	1, 7, 9	ICC, IOL/H
Interim Test I (Postburn-In)		100%/5004	1, 7, 9	ICC, IOL/H
Interim Test II (Postburn-In)		100%/5004	1, 7, 9	ICC, IOL/H
PDA		100%/5004	1, 7, 9, Deltas	
Interim Test III (Postburn-In)		100%/5004	1, 7, 9	ICC, IOL/H
PDA		100%/5004	1, 7, 9, Deltas	
Final Test		100%/5004	2, 3, 8A, 8B, 10, 11	
Group A (Note 1)		Sample/5005	1, 2, 3, 7, 8A, 8B, 9, 10, 11	
Group B	Subgroup B-5	Sample/5005	1, 2, 3, 7, 8A, 8B, 9, 10, 11, Deltas	Subgroups 1, 2, 3, 9, 10, 11, (Note 2)
	Subgroup B-6	Sample/5005	1, 7, 9	
Group D		Sample/5005	1, 7, 9	

NOTES:

1. Alternate group A inspection in accordance with method 5005 of MIL-STD-883 may be exercised.
2. Table 5 parameters only.

TABLE 7. TOTAL DOSE IRRADIATION

CONFORMANCE GROUPS	METHOD	TEST		READ AND RECORD	
		PRE RAD	POST RAD	PRE RAD	POST RAD
Group E Subgroup 2	5005	1, 7, 9	Table 4	1, 9	Table 4 (Note 1)

NOTE:

1. Except FN test which will be performed 100% Go/No-Go.

TABLE 8. STATIC AND DYNAMIC BURN-IN TEST CONNECTIONS

OPEN	GROUND	1/2 VCC = 3V ± 0.5V	VCC = 6V ± 0.5V	OSCILLATOR	
				50kHz	25kHz
STATIC BURN-IN I TEST CONNECTIONS (Note 1)					
1, 8, 9, 10, 11, 14, 15, 16	2, 3, 4, 6, 7, 12, 13	-	5	-	-
STATIC BURN-IN II TEST CONNECTIONS (Note 1)					
1, 8, 9, 10, 11, 14, 15, 16	12	-	2, 3, 4, 5, 6, 7, 13	-	-
DYNAMIC BURN-IN TEST CONNECTIONS (Note 2)					
-	12	1, 8, 9, 10, 11, 14, 15, 16	5	4, 13	2, 3, 6, 7

NOTES:

1. Each pin except VCC and GND will have a resistor of 10KΩ ± 5% for static burn-in
2. Each pin except VCC and GND will have a resistor of 1KΩ ± 5% for dynamic burn-in

TABLE 9. IRRADIATION TEST CONNECTIONS

OPEN	GROUND	VCC = 5V ± 0.5V
1, 8, 9, 14, 15, 16	12	2, 3, 4, 5, 6, 7, 10, 11, 13

NOTE: Each pin except VCC and GND will have a resistor of 47KΩ ± 5% for irradiation testing. Group E, Subgroup 2, sample size is 4 dice/wafer 0 failures.

Intersil Space Level Product Flow - 'MS'

Wafer Lot Acceptance (All Lots) Method 5007 (Includes SEM)

GAMMA Radiation Verification (Each Wafer) Method 1019, 4 Samples/Wafer, 0 Rejects

100% Nondestructive Bond Pull, Method 2023

Sample - Wire Bond Pull Monitor, Method 2011

Sample - Die Shear Monitor, Method 2019 or 2027

100% Internal Visual Inspection, Method 2010, Condition A

100% Temperature Cycle, Method 1010, Condition C, 10 Cycles

100% Constant Acceleration, Method 2001, Condition per Method 5004

100% PIND, Method 2020, Condition A

100% External Visual

100% Serialization

100% Initial Electrical Test (T0)

100% Static Burn-In 1, Condition A or B, 24 hrs. min., +125^{o}C min., Method 1015

100% Interim Electrical Test 1 (T1)

100% Delta Calculation (T0-T1)

100% Static Burn-In 2, Condition A or B, 24 hrs. min., +125^{o}C min., Method 1015

100% Interim Electrical Test 2 (T2)

100% Delta Calculation (T0-T2)

100% PDA 1, Method 5004 (Notes 1and 2)

100% Dynamic Burn-In, Condition D, 240 hrs., +125^{o}C or Equivalent, Method 1015

100% Interim Electrical Test 3 (T3)

100% Delta Calculation (T0-T3)

100% PDA 2, Method 5004 (Note 2)

100% Final Electrical Test

100% Fine/Gross Leak, Method 1014

100% Radiographic, Method 2012 (Note 3)

100% External Visual, Method 2009

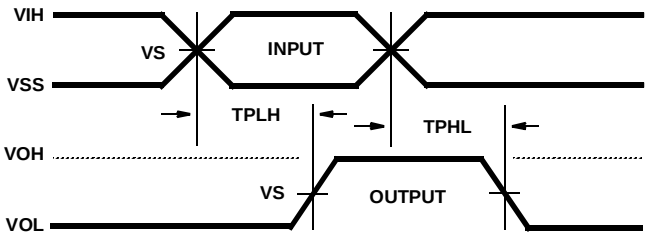
Sample - Group A, Method 5005 (Note 4)

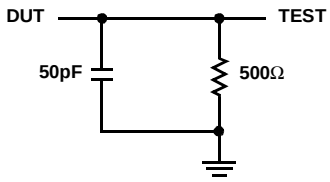
100% Data Package Generation (Note 5)

NOTES:

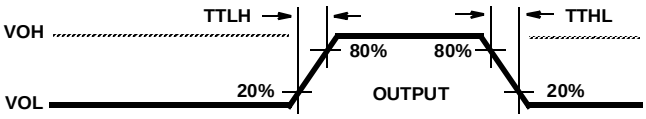
1. Failures from Interim electrical test 1 and 2 are combined for determining PDA 1.
2. Failures from subgroup 1, 7, 9 and deltas are used for calculating PDA. The maximum allowable PDA = 5% with no more than 3% of the failures from subgroup 7.
3. Radiographic (X-Ray) inspection may be performed at any point after serialization as allowed by Method 5004.
4. Alternate Group A testing may be performed as allowed by MIL-STD-883, Method 5005.
5. Data Package Contents:
   - Cover Sheet (Intersil Name and/or Logo, P.O. Number, Customer Part Number, Lot Date Code, Intersil Part Number, Lot Number, Quantity).
   - Wafer Lot Acceptance Report (Method 5007). Includes reproductions of SEM photos with percent of step coverage.
   - GAMMA Radiation Report. Contains Cover page, disposition, Rad Dose, Lot Number, Test Package used, Specification Numbers, Test equipment, etc. Radiation Read and Record data on file at Intersil.
   - X-Ray report and film. Includes penetrometer measurements.
   - Screening, Electrical, and Group A attributes (Screening attributes begin after package seal).
   - Lot Serial Number Sheet (Good units serial number and lot number).
   - Variables Data (All Delta operations). Data is identified by serial number. Data header includes lot number and date of test.
   - The Certificate of Conformance is a part of the shipping invoice and is not part of the Data Book. The Certificate of Conformance is signed by an authorized Quality Representative.

Propagation Delay Timing Diagram and Load Circuit





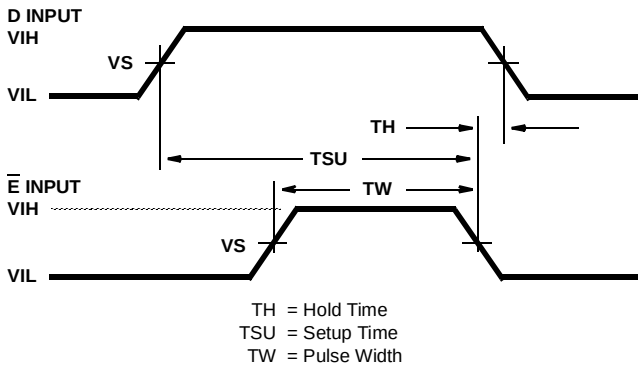
Transition Timing Diagram



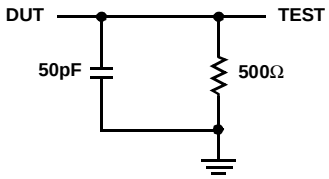
VOLTAGE LEVELS

PARAMETER	HCTS	UNITS
VCC	4.50	V
VIH	3.00	V
VS	1.30	V
VIL	0	V
GND	0	V

Pulse Width, Setup, Hold Timing Diagram and Load Circuit



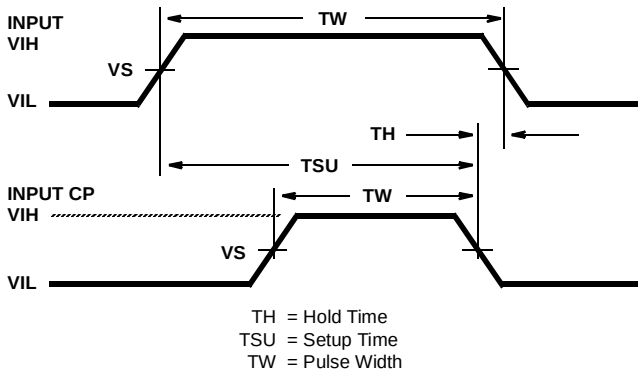
TH = Hold Time
TSU = Setup Time
TW = Pulse Width



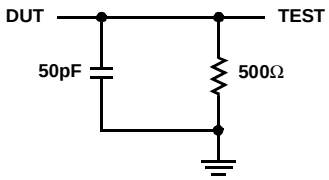
VOLTAGE LEVELS

PARAMETER	HCTS	UNITS
VCC	4.50	V
VIH	4.50	V
VS	2.25	V
VIL	0	V
GND	0	V

Pulse Width, Setup, Hold Timing Diagram Negative Edge Trigger and Load Circuit



TH = Hold Time
TSU = Setup Time
TW = Pulse Width



VOLTAGE LEVELS

PARAMETER	HCTS	UNITS
VCC	4.50	V
VIH	4.50	V
VS	2.25	V
VIL	0	V
GND	0	V

Die Characteristics

DIE DIMENSIONS:
89 x 88 mils
2.25 x 2.24mm

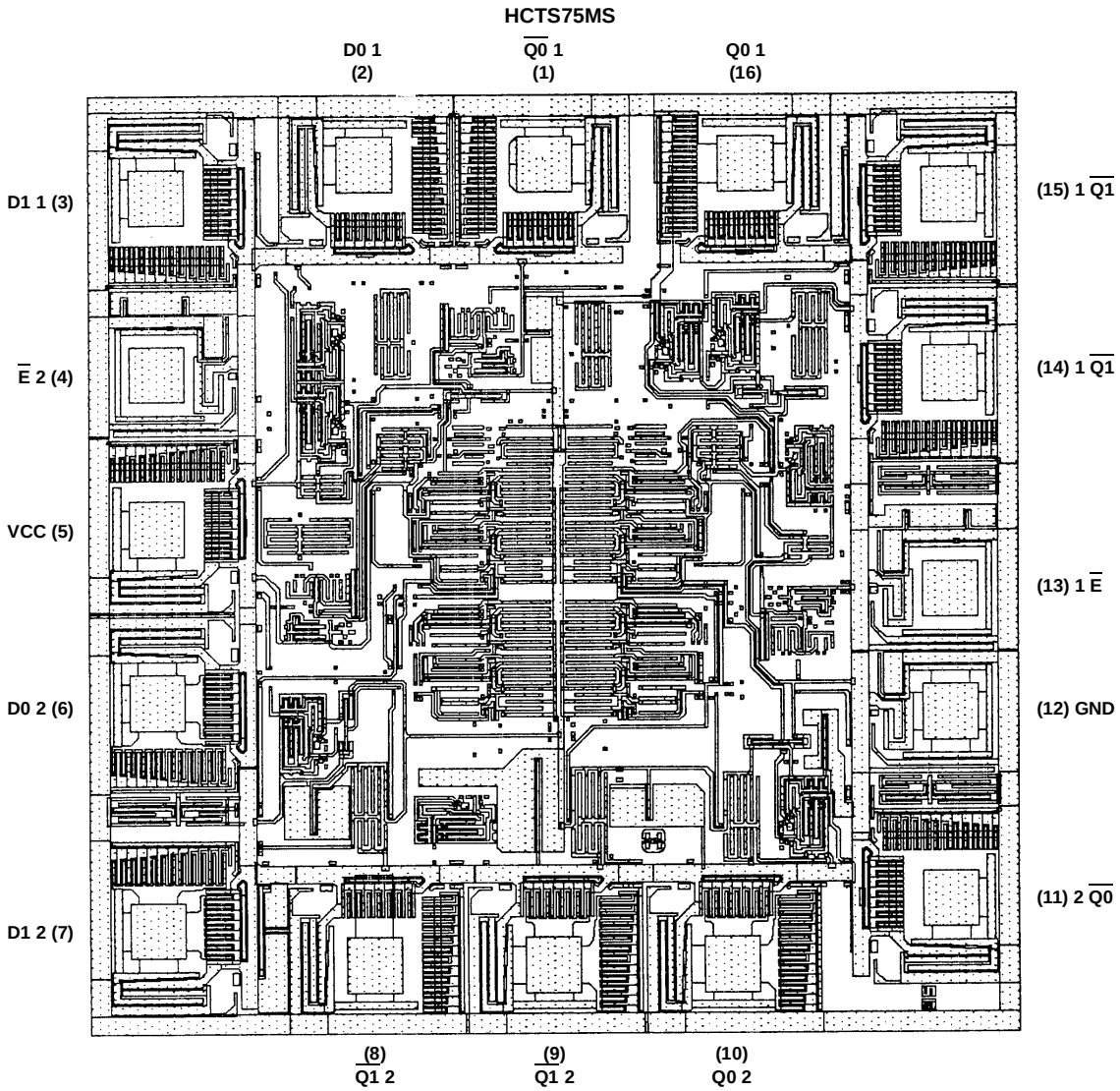
METALLIZATION:
Type: SiAl
Metal Thickness: 11kÅ ± 1kÅ

GLASSIVATION:
Type: SiO_2
Thickness: 13kÅ ± 2.6kÅ

WORST CASE CURRENT DENSITY:
$<2.0 \times 10^5 A/cm^2$

BOND PAD SIZE:
100µm x 100µm
4 x 4 mils

Metallization Mask Layout



NOTE: The die diagram is a generic plot from a similar HCS device. It is intended to indicate approximate die size and bond pad location. The mask series for the HCTS75 is TA14442A.